Patent Assignment Abstract of Title

Total Assignments: 1

Applicati n #: <u>09505695</u> **Filing Dt:** 02/17/2000

Patent #: NONE

Issue Dt:

PCT #: NONE

Publicati n #: NONE

Pub Dt:

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Title: Method of photoresist ash residue removal

Assignment: 1

Reel/Frame: 012422/0365 Received: 01/09/2002

Recorded: 01/03/2002

Mailed: 02/26/2002 Pages:

Conveyance: ASSIGNMENT OF ASSIGNORS INTEREST (SEE DOCUMENT FOR DETAILS).

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Exec Dt: 03/23/2001

Exec Dt: 03/29/2001

Exec Dt: 04/11/2001 Exec Dt: 04/11/2001

Exec Dt: 05/05/2001

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Search Results as of: 6/20/2003 10:33:33 A.M.

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